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JFw



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Patent Application of: Jae Han CHA

Serial No.: 10/612,074

Group Art Unit: 2823

Filed: July 3, 2003

Examiner: Estrada, Michelle

For: METHOD OF FORMING AN ISOLATION FILM IN A SEMICONDUCTOR  
DEVICE

\* \* \* \* \*

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents

October 15, 2004

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

As a means of complying with the duty of disclosure under 37 CFR §1.56, and in accordance with 37 CFR §§1.97 and 1.98, Applicant(s), through the undersigned attorney, submits this Information Disclosure Statement. The patents, publications or other information submitted herewith are listed on the attached Form PTO-1449 and copies are attached.

In accordance with 37 CFR §1.97(d), this Information Disclosure Statement is being filed after the mailing date of either a Final Action under 37 CFR §1.113 or a Notice of Allowance under 37 CFR §1.311 but before the payment of the Issue Fee. Therefore, certification in accordance with 37 CFR §1.97(e) is included herein.

10/18/2004 SSESHE1 00000034 10612074 180.00 DP  
01 FC:1806

The patents and publications listed on Form PTO-1449 were cited in a Korean Search Report mailed not more than three months ago in a counterpart Korean patent application. A copy of the Korean Search Report is enclosed.

A check including the amount of \$180.00 for the fee set forth in 37 CFR §1.17(p) is attached. Should any additional fee be required by the filing of this statement, please charge such fee to Deposit Account No. 50-3226. A duplicate copy of this paper is enclosed.

CERTIFICATION

It is hereby certified that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application no more than three months prior to the filing of this statement.

Respectfully submitted,  
Piper Rudnick LLP

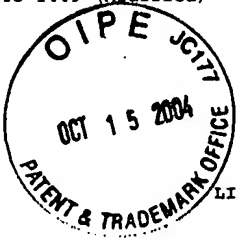
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## LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

ATTY. DOCKET NO.: 312971-P0023  
SERIAL NO.: 10/612,074  
APPLICANT(S): Jae Han CHA

GROUP ART UNIT: 2823  
FILING DATE: July 3, 2003  
TODAY'S DATE: October 15, 2004

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## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	INT'L CLASS	SUB- CLASS	FILING DATE (If Appropriate)
AA						
AB						
AC						

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## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION (YES) (NO)
AD	990028402	7/14/1999	Korea	H01L	21/76	X
AE						

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## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AG \_\_\_\_\_  
\_\_\_\_\_  
AH \_\_\_\_\_  
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EXAMINER

DATE CONSIDERED

\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).